

ABSTRACT OF THE DISCLOSURE

PROCESS FOR MAKING A LAYER OF MATERIAL ON A SUPPORT

The invention relates to a process for manufacturing of a fragmented layer of material on a support, characterised in that it comprises:

a deposition step for depositing a continuous thin layer (14) of this material on said support, in a discontinuous manner,

followed by a step for putting this thin layer into drops Processes for preparing catalyst structures, include forming a layer of a catalytic material on a substrate, and separating the layer of the catalytic material into droplet-shaped bodies of the catalytic material adhered to the substrate.

Figure 2.